

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Docket No.: P2381US00

Jong-Lam LEE, *et. al.*

Serial No.: 10/597,200

Group Art Unit: 2818

Confirmation No.: 7656

Filed: July 14, 2006

Examiner: NGUYEN, Thinh T.

For: **GALLIUM NITRIDE-BASED III-V GROUP COMPOUND SEMICONDUCTOR DEVICE
AND METHOD OF MANUFACTURING THE SAME**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Sir:

In reply to the January 8, 2009 Restriction Requirement, Applicants elect Group I,
including claims 1-7, without traverse.

It is not believed that any extensions of time or fees are required. If extensions of time
are necessary to prevent abandonment of this application, then such extensions of time are
hereby petitioned for under 37 C.F.R. §1.136(a) and are hereby authorized to be charged to our
Deposit Account No. 50-3698.

Respectfully submitted,

/hae-chan park/

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Dated: February 3, 2009

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